

THE UNITED STATES PATENT AND TRADEMARK OFFICEApplicant: Bronner *et al.*

Art Unit: 2814

Serial No.: 09/105,739

Dkt. No.: BU9-97-149

Filed: 6/26/98

Examiner: Rao, Shrinivas H.

Title: SELF-ALIGNED SURFACE-TRAP MINT DRAM CELLCommissioner for Patents
Washington, DC 20231

5/21/03

AMENDMENT

Sir:

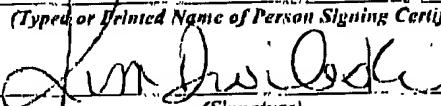
In response to the Final Office Action mailed March 17, 2003, please amend the above-identified application as follows:

In the Claims:

Currently pending claims 1-29 for consideration by the Examiner are as follows:

1. (Previously Amended) A method for forming an interconnection between a storage capacitor and a transfer device in a memory cell, the method comprising the steps of:

- a) forming a capacitor having a lip extending over a top surface of a substrate; and
- b) diffusing dopant from the lip into the top surface of the substrate, the diffusing dopant forming a surface strap in the substrate, the surface strap providing a connection between the capacitor and the transfer device.

CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)			
Applicant(s): Brouner et al.			
Serial No. 09/105,739	Filing Date 6/26/98	Examiner Rao, Shrinivas H.	Docket No. BU9-97-149
Invention: SELF-ALIGNED SURFACE-TRAP MINT DRAM CELL.			
<p>I hereby certify that this <u>Amendment (18 pages)</u> <small>(Identify type of correspondence)</small> is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>703-308-7722</u> on <u>5/19/2003</u> <small>(Date)</small></p>			
<p style="text-align: center;">Kim Dwileski <small>(Typed or Printed Name of Person Signing Certificate)</small>  <small>(Signature)</small></p>			
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